

Notice of References Cited

Application/Control No.

10/003,856

Applicant(s)/Patent Under
Reexamination
AGARWALA ET AL.

Examiner

Kim T. Huynh

Art Unit

2112

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,496,740	12-2002	Robertson et al.	700/20
*	B	US-6,662,306	12-2003	Van Loo, William C.	713/600
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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